



18W/1756

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI

Group Art Unit: 1756

Application No.: 10/523,470

Filed: March 10, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK BLANK, METHOD FOR
MANUFACTURING TRANSFER MASK, SPUTTERING TARGET FOR
MANUFACTURING MASK BLANK

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to Reference 1 of the PTO Form 1449 filed concurrently with the Information Disclosure Statement on November 14. It is respectfully requested that the reference be expressly considered in view of the attached English-language translation of a Korean Office Action, which provides a further concise explanation of potential relevance of the reference. JP 2001-303243, also cited in the Office Action, was disclosed to the Patent and Trademark Office in and Information Disclosure Statement filed on March 10, 2005.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

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Date: December 29, 2006

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